

Notice of References Cited

Application/Control No.

09/980,754

Applicant(s)/Patent Under
Reexamination
LERCH ET AL.

Examiner

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Art Unit

2823

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Wolf, Stanley and Tauber, Richard N.; Silicon processing for the VLSI Era Vol 1: Process Technology; 1986, Lattice press, pgs.192-194.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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